	Application No. Applican			
Notice of Allowability	09/839,296	339,296 AOYAGI ET AL.		
	Examiner	Art Unit		
	HOAN C. NGUYEN	2871	AN	
The MAILING DATE of this communication appears on the cover sheet with the correspondence address All claims being allowable, PROSECUTION ON THE MERITS IS (OR REMAINS) CLOSED in this application. If not included herewith (or previously mailed), a Notice of Allowance (PTOL-85) or other appropriate communication will be mailed in due course. THIS NOTICE OF ALLOWABILITY IS NOT A GRANT OF PATENT RIGHTS. This application is subject to withdrawal from issue at the initiative of the Office or upon petition by the applicant. See 37 CFR 1.313 and MPEP 1308.				
1. This communication is responsive to <u>07/01/04</u> .				
2. The allowed claim(s) is/are 7-11 and 14-23.				
3. The drawings filed on 23 April 2001 are accepted by the Examiner.				
 4. Acknowledgment is made of a claim for foreign priority una) All b) Some* c) None of the: 1. Certified copies of the priority documents have 2. Certified copies of the priority documents have 3. Copies of the certified copies of the priority documents have International Bureau (PCT Rule 17.2(a)). * Certified copies not received: 	e been received. e been received in Application N	No	ion from the	
Applicant has THREE MONTHS FROM THE "MAILING DATE" noted below. Failure to timely comply will result in ABANDONN THIS THREE-MONTH PERIOD IS NOT EXTENDABLE.		reply complying with the req	uirements	
5. A SUBSTITUTE OATH OR DECLARATION must be subm INFORMAL PATENT APPLICATION (PTO-152) which giv			OTICE OF	
 CORRECTED DRAWINGS (as "replacement sheets") must (a) including changes required by the Notice of Draftspers 1) hereto or 2) to Paper No./Mail Date (b) including changes required by the attached Examiner Paper No./Mail Date Identifying indicia such as the application number (see 37 CFR 1 each sheet. Replacement sheet(s) should be labeled as such in the sheet. Replacement sheet(s) should be labeled as such in the deposit of the same properties. DEPOSIT OF and/or INFORMATION about the deposit of the deposit of the same properties. 	son's Patent Drawing Review ('s Amendment / Comment or in 1.84(c)) should be written on the comment according to 37 CFR 10 sit of BIOLOGICAL MATER	the Office action of drawings in the front (not the .121(d). IAL must be submitted. N	·	
attasted Examiner of comment regarding (Cachicine)	· ·	OTONE WATERIAL.		
Attachment(s)	E - November 6	and Defend And Park Comme) 450)	
 Notice of References Cited (PTO-892) D Notice of Draftperson's Patent Drawing Review (PTO-948) 	5. ☐ Notice of Information6. ☐ Interview Sum	mal Patent Application (PTC mary (PTO-413))-152)	
3. ☐ Information Disclosure Statements (PTO-1449 or PTO/SB/0	Paper No./Ma	Paper No./Mail Date Examiner's Amendment/Comment		
Paper No./Mail Date	<u>_</u>			
4. Examiner's Comment Regarding Requirement for Deposit	8. ⊠ Examiner's Sta 9.	atement of Reasons for Allo	wance	
of Biological Material	9. [] Other			

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EXAMINER'S AMENDMENT

1. An examiner's amendment to the record appears below. Should the changes and/or additions be unacceptable to applicant, an amendment may be filed as provided by 37 CFR 1.312. To ensure consideration of such an amendment, it MUST be submitted no later than the payment of the issue fee.

Authorization for this examiner's amendment was given in a telephone interview with Mr. Miller on 7/20/2004.

Mr. Miller authorizes to cancel claims 12-13.

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DETAILED ACTION

Applicant cancelled claims1-6 and 12-13. Therefore, claims 7-11 and 14-23 are still pending.

Allowable Subject Matter

Claims 7-11 and 14-23 are allowed.

Reasons for Allowance

Claims 7, 11 and 23 are allowed since there is no prior art teaches a method of manufacturing a LCD device comprising:

- Cutting apart a first rectangular substrate from a first raw glass substrate such that a longer side direction of a first rectangular substrate is coincident with a drawing direction of the first raw glass substrate.
- Cutting apart a second rectangular substrate from a second raw glass substrate such that a longer side direction of a first rectangular substrate becomes orthogonal (perpendicular) to a drawing direction of the second raw glass substrate.

wherein <u>line-shaped protrusions along a drawing direction</u> of the first and second raw glass substrates.

Claims 8-10 and 12-22 are allowed since they depend on the allowed claims.

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Furthermore, in the interview with Mr. Miller on July 13, 2004, Mr. Miller also confirmed that color filter 142 and common electrode 106, TFT with scanning line 520 and signal line 103 are formed DIRECTLY ON one of "irregular surfaces" 101'/102' of substrates 101/102; where the "surface irregularity" is small relative to the size (in order of micron) of the substrate.

Any comments considered necessary by applicant must be submitted no later than the payment of the issue fee and, to avoid processing delays, should preferably accompany the issue fee. Such submissions should be clearly labeled "Comments on Statement of Reasons for Allowance."

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to HOAN C. NGUYEN whose telephone number is (571) 272-2296. The examiner can normally be reached on MONDAY-THURSDAY:8:00AM-4:30PM.

If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Kim H Robert can be reached on (571) 272-2293. The fax phone number for the organization where this application or proceeding is assigned is 703-872-9306.

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Information regarding the status of an application may be obtained from the Patent Application Information Retrieval (PAIR) system. Status information for published applications may be obtained from either Private PAIR or Public PAIR. Status information for unpublished applications is available through Private PAIR only. For more information about the PAIR system, see http://pair-direct.uspto.gov. Should you have questions on access to the Private PAIR system, contact the Electronic Business Center (EBC) at 866-217-9197 (toll-free).

HOAN C. NGUYEN Examiner Art Unit 2871

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SUPERVISORY PATENT EXAMINER
TECHNOLOGY CENTER 2800